IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

H. ARAI et al.

Serial No. 10/091,426 Group Art Unit: 2827

Filed: March 7, 2002 Examiner: D. Zarneke

For: A SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING

THE SAME

SECOND REQUEST FOR CONSIDERATION OF PRIORITY DOCUMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Applicants would appreciate the Examiner's acknowledgment of the claim for priority and receipt of the priority document filed on December 10, 2004.

Respectfully submitted,

John R. Matting 1/2

Registration No. 30,293 Attorney for Applicants

MATTINGLY, STANGER & MALUR 1800 Diagonal Rd., Suite 370 Alexandria, Virginia 22314 (703) 684-1120

Date: February 23, 2005



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TRANSMITTAL OF CERTIFIED PRIORITY DOCUMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Submitted herewith is a certified priority document

(JP 2001-083180) of a corresponding Japanese patent

application for the purpose of claiming foreign priority under

35 U.S.C. § 119. An indication that this document has been safely received would be appreciated.

Respectfully submitted,

John R. Mattingly

Registration No. 20293 Attorney for Applicants

MATTINGLY, STANGER & MALUR 1800 Diagonal Rd., Suite 370 Alexandria, Virginia 22314 (703) 684-1120

Date: December 10, 2004



日本国特許庁 JAPAN PATENT OFFICE

別紙添付の書類に記載されている事項は下記の出願書類に記載されている事項と同一であることを証明する。

This is to certify that the annexed is a true copy of the following application as filed with this Office

出願年月日

Date of Application:

2001年 3月22日

出願番号

Application Number:

特願2001-083180

[ST.10/C]:

[JP2001-083180]

出 願 人 Applicant(s):

株式会社日立製作所

日立北海セミコンダクタ株式会社

2002年 3月19日

特許庁長官 Commissioner, Japan Patent Office

